## **Program of workshop**

## "Newest innovations for semiconductor industry from Saxony and Japan for better energy efficiency"

on December 5<sup>th</sup>

at New Otani Hotel, Akasaka, Yu-room, The Main, Arcade floor 4-1, Kioi-cho, Chiyoda-ku, Tokyo 102-8578 phone +81 3 3265 1111, Fax +81 3 3221 2619 http://www.newotani.co.jp/en/tokyo/	
14:30	Welcome Wolfgang Freese, Saxony Economic Development Corporation
14:35	short overview, "Business Opportunities in Saxony" Karin Heidenreich, Saxony Economic Development Corporation
14:50	"Growing Semiconductur Industry in Saxony - New Innovations!" Gitta Haupold, Silicon Saxony
15:10	"3D Heterogeneous Integration - Opportunity for Smart System Integration" Jürgen Wolf, Fraunhofer ASSID,
15:30	"New technologies for today's challenges - Research at the Fraunhofer CNT" Dr. Benjamin Uhlig, Fraunhofer CNT,
15:50	"New Energy Efficient Waste Gas and Waste Water Treatment Technologies" Dr. Horst Reichardt, DAS Environmental Expert,
16:10	"Hitachi's R&D in organic electronics aimed for high energy efficiency; organic TFT & OLED" Dr. Takeo Shiba and Sukekazu Aratani, Hitachi Research Center
16:30	coffee break
16:50	"Cleanroom suitability of equipments and materials for clean production environments Dr. Udo Gommel, Fraunhofer IPA
17:10	"New recycling Strategies for Hightech and Greentech Waste - made in Saxony" Dr. Wolfram Palitzsch, Loser Chemie,
17:30	"Approach to Energy Field in Toppan Printing" Dr. Takao Tomono, Toppan Printing,
17:50	"Results of Delegation about Recent Visit to Dresden" Yutaka Makino, SIIQ Kyushu
18:10	"HSEB - Advanced Inspection Solutions" Burkhardt Stegemann , HSEB
18:30	"Intelligent Fluids of bubbles&beyond for Microelectronics"  Manabu Uchida JNC Corporation

19:00 Reception at Sho-room, Arcade Floor

simultaneous translation English-Japanese-English is provided

18:50 closing remarks